

## PATENT ABSTRACTS OF JAPAN

(11)Publication number : 2002-230246

(43)Date of publication of application : 16.08.2002

(51)Int.Cl.

G06F 17/60

(21)Application number : 2001-030381

(71)Applicant : HITACHI LTD

(22)Date of filing : 07.02.2001

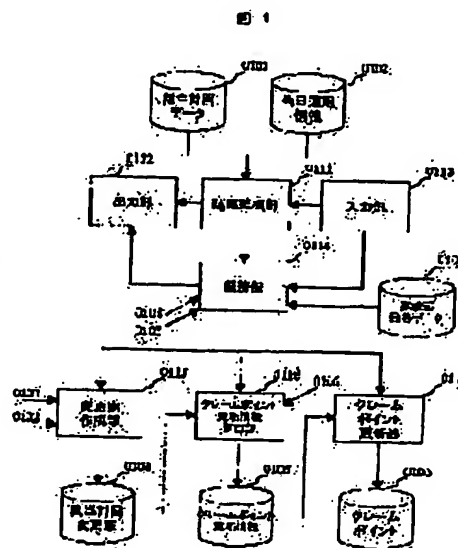
(72)Inventor : SATO TATSUHIRO  
KANDA CHIKAYO  
SASAKI TOSHIRO

## (54) RESOURCE ALLOCATION MANAGEMENT SYSTEM

## (57)Abstract:

**PROBLEM TO BE SOLVED:** To provide a resource allocation management system allowing a person in charge to be able to change an allocation plan and to perform the adjustment among persons concerned efficiently with a small load, in a resource allocation management for monitoring and controlling the use thereof by allocating finite resources to a plurality of jobs.

**SOLUTION:** When a resource allocation plan is changed by giving a point 0106 to a job requester, based on allocation plan data 0101 and an operation information on the day 0102, a plurality of allocation plan change plans are prepared 0115 and, based on the allocation plan change plans, point updating information 0105 showing the point variation of the job requester before and after the change plans are executed is calculated 0116. A coordination part 0114 selects an optimum allocation plan change plan based on the point updating information, notifies the job requester of the optimum allocation plan change plan and the point updating information and, based on the reply 0103 of approval or disapproval to the notification from the job requester, performs again the selection and notification of the change plan or determines the change plan to update the point based on a request history from the job requester up to the definition of the point updating information and change plan for the change plan.



## LEGAL STATUS

[Date of request for examination]

[Date of sending the examiner's decision of rejection]

[Kind of final disposal of application other than the examiner's decision of rejection or application converted registration]

[Date of final disposal for application]

[Patent number]

<http://www19.ipdl.ncipi.go.jp/PA1/result/detail/main/wAAA5caybRDA414230246...> 2005/11/10

BEST AVAILABLE COPY